

Contribution ID: 1295 Contribution code: WEPL144 Type: Poster Presentation

Impedance measurements of key elements in the HEPS

Wednesday, 10 May 2023 16:30 (2 hours)

Impedance modeling is an important subject in diffraction limited storage rings based light sources, due to the adopted small beam pipe as well as the tight requirements from beam collective effects. Therefore, a batch of impedance bench measurements are performed or planned for the dominant impedance contributors in HEPS, including resistive wall impedance of the NEG coated vacuum chambers, as well as the geometrical impedance of components with large impedance for single element or that show large contributions due to large quantities. In this paper, the impedance measurement of the key elements in the HEPS will be discussed, and the main results are given and compared with the theoretical estimations.

Funding Agency

NSFC (11775239), Youth Innovation Promotion Association CAS, and innovation study of IHEP

Footnotes

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Presenter: WANG, Na (Chinese Academy of Sciences)Session Classification: Wednesday Poster Session

Track Classification: MC5: Beam Dynamics and EM Fields: MC5.D04: Beam Coupling Impedance Theory, Simulations, Measurements, Code Developments